
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 213.002-D1-US)

In the Application of: YE ET AL.

) Group
) Art Unit: 2878

Serial No: 10/646,313

)
) Before

Filed: August 22, 2003

) Examiner: Que Tan Le

Title: System and Method for Lithography Process
Monitoring and Control

)
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FACSIMILE COVER SHEET

DATE: June 8, 2004

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Dear Mr. Fairchild,

As you requested in our telephone conversation of today, enclosed please find page 40 of the specification, as filed.

I understand from our conversation that page 40 was rendered unusable, for the purposes of issuance, by the USPTO.

Please let me know if you have any questions.

Respectfully submitted,



Neil A. Steinberg
Phone: 650-968-8079

Dated: June 8, 2004